

Title (en)
SUBSTRATE TREATMENT INSTALLATION

Title (de)
SUBSTRATBEHANDLUNGSANLAGE

Title (fr)
INSTALLATION DE TRAITEMENT DE SUBSTRATS

Publication
EP 2702608 A1 20140305 (DE)

Application
EP 12718967 A 20120427

Priority
• DE 102011100098 A 20110429
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Abstract (en)
[origin: WO2012146715A1] A problem addressed by the invention, namely that of improving known substrate treatment installations such that substrates can be treated by light in said installations, without the need for cost-intensive inspection windows having a large thickness, is solved by means of a substrate treatment installation comprising an installation chamber and a light source for the exposure of substrates to light, the light source being arranged in the interior of the substrate treatment installation and comprising at least one lamp arranged in a housing, which is permeable to light at least in sections and has a vacuum-tight cavity for accommodating a lamp, and also comprising at least one reflector element arranged in spatial proximity to the at least one lamp and having an electrical connection.

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H01L 21/67 (2006.01)

CPC (source: CN EP US)
H01J 7/26 (2013.01 - US); **H01J 37/32522** (2013.01 - US); **H01L 21/67115** (2013.01 - CN EP US)

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See references of WO 2012146715A1

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US 3733599 A 19730515 - FANTOZZI L

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DOCDB simple family (publication)
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